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Karen Cinq-Mars

(Signature)

(Date)

SEP 30 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of _____: September 30, 2004
Huang et al. _____: Group Art Unit: 1752
Serial No. 10/693,199 _____: Examiner: Amanda C. Walke
Filed: 10-24-03 _____: IBM Corporation
Title: LOW-ACTIVATION ENERGY Dept. 18G/Bldg. 300-482
SILICON-CONTAINING 2070 Route 52
RESIST SYSTEM _____: Hopewell Junction,
New York 12533

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to
the document listed on the enclosed Form PTO-1449.

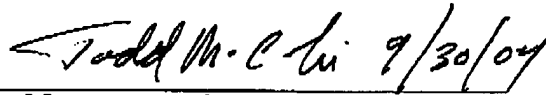
It is respectfully requested that the above information be
considered by the Examiner and that a copy of the enclosed Form
PTO-1449 be returned indicating that such information has been
considered.

Applicants undersigned attorney may be reached by telephone
at (845) 894-6919. All correspondence should continue to be

FIS9-2003-0330US1

directed to the below listed address.

Respectfully submitted,

 Todd M. C. Li 9/30/04

Todd M. C. Li
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TML/kcm

FIS9-2003-0330US1

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) FIS920030330US1		Application Number 10/693,199		
				Applicant(s) Huang et al.				
				Filing Date 10-24-03		Group Art Unit 1752		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
		6,309,796	10-30-01	Nakashima et al.				
U.S. PATENT APPLICATION PUBLICATIONS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
EXAMINER				DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								